

ENGLISH TRANSLATION PARAGRAPHS 0061 & 0062:

[0061] FIG. 1 is a longitudinal cross-sectional view illustrating the structure of a sensor according to a first embodiment of the invention;

FIG. 2 is a longitudinal cross-sectional view illustrating the structure of a sensor according to a second embodiment of the invention;

FIG. 3 is a longitudinal cross-sectional view illustrating the structure of a sensor according to a third embodiment of the invention; and

FIG. 4 is a perspective view illustrating the structure of a sensor according to a fourth embodiment of the invention.

- [0062]
1. Crystal (an optical waveguide path)
 2. Crystal oscillation electrode
 3. Crystal oscillation electrode (optical waveguide electrode, optical waveguide path)
 4. Clad
 5. Core
 6. Metallic thin film
 7. Adsorbed-substance detecting thin film
 8. Incoming light prism
 9. Outgoing light prism
 10. Crystal oscillator
 11. Adsorption member
 12. Optical waveguide layer (optical waveguide path)
 - 15,16 Electrodes
 17. Gold colloids (a metallic colloid layer)
 18. Substrate
 19. Piezoelectric element
 - 20a, 20b Comb-like opposing electrodes
 21. Surface elastic wave element

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Appl. No. 10/591,196
Page 3

AMENDMENT TO THE SPECIFICATION:

Please cancel paragraphs 0061 and 0062 from the specification.